IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Heidi Cao et al.	Art Unit:	1752
Serial No.:	10/686,031	Examiner:	Amanda C. Walke
Filed:	October 14, 2003	Assignee:	Intel Corporation
Title:	PHOTORESISTS WITH REDUCED OUTGASSING FOR EXTREME ULTRAVIOLET LITHOGRAPHY		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR ONE-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated August 10, 2006, be extended for one month to and including December 10, 2006.

Please apply the $120 fee and any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: November 28, 2006

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BY
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